



Docket No.: SON-1718
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Yasukiyasu Sugano et al.

Application No.: 09/478,812

Confirmation No.: 2204

Filed: January 7, 2000

Art Unit: 2815

For: PROCESS FOR PRODUCING THIN FILM
SEMICONDUCTOR DEVICE AND LASER
IRRADIATION APPARATUS

Examiner: Eugene Lee

AMENDMENT

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the non-final Office Action dated February 15, 2006, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks/Arguments begin on page 12 of this paper.